



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: H. ATWATER et al.

Title: WAFER BONDED EPITAXIAL
TEMPLATES FOR SILICON
HETEROSTRUCTURES

Appl. No.: 10/784,586

Filing Date: 2/23/2004

Examiner: Unassigned

Art Unit: 1764

PRELIMINARY AMENDMENT UNDER 37 CFR 1.115

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to examination of the present Continuing Application, Applicant respectfully requests that the application be amended as follows:

Amendments to the Specification begin on page 2 of this document.

Amendments to the Claims are reflected in the listing of claims which begins on page 9 of this document.

Amendments to the Drawings begin on page 13 of this document, and include an attached replacement drawing sheet and an annotated sheet showing changes.

Remarks/Arguments begin on page 14 of this document.

Please amend the application as follows:

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